IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s): SAKAKIBARA Atty. Dkt.: 01-278-DIV

Serial No.: Unknown Group Art Unit:

Filed: Concurrently herewith Examiner:

Title: SEMICONDUCTOR DEVICE AND

METHOD FOR MANUFACTURING

SEMICONDUCTOR DEVICE

Commissioner for Patents Date: October 30, 2003

Arlington, VA 22202

INFORMATION DISCLOSURE STATEMENT

Sir:

Pursuant to 37 C.F.R. §1.56, the reference(s) listed on the attached Form PTO-1449 is/are being submitted for consideration by the Examiner without any admission that it/they constitute(s) statutory prior art, or without any admission that it/they contain(s) subject matter that anticipates the invention or renders the invention obvious to a person of ordinary skill in the art.

The Examiner is requested to initial the attached PTO Form-1449 and to return a copy of same to the undersigned attorney as proof that the listed reference(s) has/have been considered and made of record.

Respectfully submitted,

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* PATENT APPLICATION

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FORM PTO-1449	ATTY. DKT NO.	01-278-DIV	SER. NO.	
	APPLICANT	APPLICANT SAKAKIBARA		
	FILING DATE	October 30, 2003	GROUP	

REFERENCE DESIGNATION

U.S. PATENT DOCUMENTS

EXAMINER INITIAL	DOCUMENT NUMBER	DATE	TE NAME		SUB CLASS
	6,525,375	Feb. 25, 2003	Yamaguchi et al.		
	5,216,275	June 1, 1993	Chen		
	5,438,215	Aug. 1, 1996	Tihanyi		
	5,828,101	Oct. 27, 1998	Endo		
	6,281,547	Aug. 28, 2001	So et al.		

FOREIGN PATENT DOCUMENTS

TRANSLATION

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DOCUMENT NUMBER	DATE	COUNTRY	NAME	CLASS	SUB CLASS	YES	N O
 JP-A-4-162572 *	6/8/92	JAPAN				X (Abstract)	
JP-A-61-125174 *	6/12/86	JAPAN				X (Abstract)	
JP-A-5-82782 *	4/2/93	JAPAN				X (Abstract)	
JP-A-8-204195 *	8/9/96	JAPAN				X (Abstract)	
JP-A-10-214969 *	8/11/98	JAPAN				X (Abstract)	
JP-A-11-103058 *	4/13/99	JAPAN				X (Abstract)	
JP-A-11-150265 *	6/2/99	JAPAN				X (Abstract)	
JP-A-3-283669 *	12/13/91	JAPAN				X (Abstract)	
JP-A-64-9662 *	1/12/89	JAPAN				X (Abstract)	
JP-A-63-66963 *	3/25/88	JAPAN				X (Abstract)	

^{*} Full English text of the JP Document will be available in machine-translated form from JP (Japanese Patent Office) English language web site at http://www1.ipdl.jpo.go.jp/PA1/cgi-bin/PA1INDEX.

OTHER REFERENCES (including Author, Title, Date, Pertinent Pages, etc.)

EXAMINER	<u> </u>	DATE CONSIDERED			

Rev. 10/94 (Form 3.05)